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| Substitute Form PTO-1449 (Modified) Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b)) | U.S. Department of Commerce Patent and Trademark Office | Attorney Docket No. 20228-0013US1 | Application No. 10/580,698 |
| | Applicant Damian Fiolka et al. | | |
| | Filing Date November 29, 2006 | Group Art Unit 2872 | |

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| Examiner Signature | Date Considered |
| EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | |